

Application/Control No.	Applicant(s)/Patent under Reexamination		
10/615,303	NISHIO, MASAHIRO		
Examiner	Art Unit		
Krisna Lim	2153		

SEARCHED					
Class	Subclass	Date	Examiner		
709	245, 249	10/13/2007	KL		
370	230	10/13/2007	KL		

INTERFERENCE SEARCHED					
Subclass	Date	Examiner			
245, 249	10/13/2007	KL			
	Subclass	Subclass Date			

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